



RCE 22W
PATENT

Attorney Docket No.: IMEC306.001AUS
Date: April 4, 2006
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REQUEST FOR CONTINUED EXAMINATION (RCE)
UNDER 37 C.F.R. § 1.114

Applicant: Szlufcik, et al.

Application Number: 10/609,015

Filing Date: June 27, 2003

Title: SEMICONDUCTOR ETCHING
PASTE AND THE USE THEREOF
FOR LOCALIZED ETCHING OF
SEMICONDUCTOR SUBSTRATES

Examiner Name: Lan Vinh

Group Art Unit: 1765

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Mail Stop RCE, Alexandria, VA 22313-1450, on

April 4, 2006

(Date)

Rose M. Thressen, Reg. No. 40,202

Commissioner for Patents
P.O. Box 1450
Mail Stop RCE
Alexandria, VA 22313-1450

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

1. Submission Required under 37 C.F.R. § 1.114:

Previously submitted:

Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on March 6, 2006.

Enclosed:

Copy of Amendment/Reply

Return Postcard

2. Fees:

RCE fee (\$790 large entity)

3. Payment:

(X) Check in the amount of \$790 to cover the above fees.

(X) The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. § 1.16 and § 1.17 which may be required, now or in the future, or credit any overpayment to Deposit Account No. 11-1410.

Address all future communications to Customer No. 20,995.

Dated:

4/4/06



Rose M. Thiessen
Registration No. 40,202
Attorney of Record
Customer No. 20,995
(619) 235-8550

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